



**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT PTO-1449**

Docket No. <b>52433/830</b>	Application No. <b>10/561,133</b>
Applicant(s) <b>Natsuko SUGIURA, et al.</b>	Examiner <b>Deborah YEE</b>
Filing Date <b>December 15, 2005</b>	Confirmation No. <b>6256</b>
	Art Unit <b>1793</b>

**U. S. PATENT DOCUMENTS**

EXAMINER INITIAL	PATENT/PUBLICATION NUMBER	PATENT/PUBLICATION DATE mm/dd/yyyy	NAME	CLASS	SUBCLASS	FILING DATE

**FOREIGN PATENT DOCUMENTS**

EXAMINER INITIAL	DOCUMENT NUMBER	DATE mm/dd/yyyy	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						Yes	No
/D.Y./	2001-064750	03/13/2001	JP	_____	_____	Abstract	
/D.Y./	98/32889	07/30/1998	PCT	_____	_____	Abstract	
/D.Y./	1246161	03/01/2000	CN	_____	_____	corresponding to WO 98/32889	

**OTHER DOCUMENTS**

EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.
/D.Y./	Chinese Patent issued March 12, 2008 in corresponding Chinese Patent Application No.: CN 200480017463.3

EXAMINER	/Deborah Yee/	DATE CONSIDERED	09/12/2008
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.			